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Atty Docket: ZIMR/0018

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Respectfully submitted,



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| Substitute for form 1449A/PTO                                                                     |   | <b>Complete if Known</b> |                |
|                                                                                                   |   | Application Number       | To be assigned |
| <b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br><br>(Use as many sheets as necessary) |   | Filing Date              | Herewith       |
|                                                                                                   |   | First Named Inventor     | Jürgen FROSIEN |
|                                                                                                   |   | Art Unit                 | Unknown        |
|                                                                                                   |   | Examiner Name            | Unknown        |
|                                                                                                   |   | Attorney Docket Number   | ZIMR/0018      |
| Sheet                                                                                             | 2 | of                       | 2              |

| NON PATENT LITERATURE DOCUMENTS |                       |                                                                                                                                                                                                                                                                                                                                                     |                |
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|                                 |                       | HARAGUCHI, T., et al., "Development of Electromagnetic Lenses for Multielectron Beam Lithography System," <i>Journal of Vacuum Science &amp; Technology B</i> , (Microelectronics and Nanometer Structures), Nov. 2002, AIP for American Vacuum Soc., USA, Vol. 20, No. 6, Nov. 2002, pp. 2726-29, XP002251379, ISSN: 0734-211X, the whole document |                |
|                                 |                       | Patent Abstracts of Japan, Vol. 2002, No. 09, September 4, 2002                                                                                                                                                                                                                                                                                     |                |
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